

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Confirmation No.: 9428
Shunpei YAMAZAKI , et al.)
Serial No. 10/678,139) Examiner: Mary A. Wilczewski
Filed: October 6, 2003) Group Art Unit: 2822
For: METHOD FOR FABRICATING SEMICONDUCTOR THIN FILM)

AMENDMENT UNDER 37 C.F.R. § 1.114

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated October 22, 2010, please consider Applicants' remarks as follows.

Amendments to the Specification begin on page 2 of this paper.

A Listing of the Claims begin on page 3 of this paper.

Remarks begin on page 8 of this paper.